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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/602,716	06/25/2003	Chandra Mouli	M4065.0904/P904	9955
24998	7590 08/02/2005		EXAMINER	
DICKSTEIN	N SHAPIRO MORIN & (KANG, DONGHEE		
2101 L Street, NW Washington, DC 20037			ART UNIT	PAPER NUMBER
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Please find below and/or attached an Office communication concerning this application or proceeding.

		AX
	Application No.	Applicant(s)
Office Action Summant	10/602,716	MOULI, CHANDRA
Office Action Summary	Examiner	Art Unit
	Donghee Kang	2811
The MAILING DATE of this communication ap Period for Reply	ppears on the cover sheet w	ith the correspondence address
A SHORTENED STATUTORY PERIOD FOR REPI THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a report of the provision of the period for reply specified above, the maximum statutory period for reply within the set or extended period for reply will, by stature that the period for reply will be statuted by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a ply within the statutory minimum of thin will apply and will expire SIX (6) MOI te, cause the application to become Al	reply be timely filed ty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).
Status		
3) Since this application is in condition for allowed	is action is non-final. ance except for formal mat	
closed in accordance with the practice under	Ex parte Quayle, 1935 C.L	7. 11, 433 O.G. 213.
Disposition of Claims		
4) ⊠ Claim(s) <u>1-77</u> is/are pending in the application 4a) Of the above claim(s) <u>14-23,25-29,42-48</u> , 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) <u>1-13, 24, 30-41, 49-62 and 72</u> is/are 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/	<u>63-71 and 73-77</u> is/are with e rejected.	ndrawn from consideration.
Application Papers		
9) The specification is objected to by the Examir	ner.	
10) The drawing(s) filed on is/are: a) ac		by the Examiner.
Applicant may not request that any objection to the		
Replacement drawing sheet(s) including the corre	·	
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bure * See the attached detailed Office action for a list	nts have been received. nts have been received in <i>i</i> iority documents have beer au (PCT Rule 17.2(a)).	Application No n received in this National Stage
Attachment(s)		
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/03)	Paper No	Summary (PTO-413) (s)/Mail Date Informal Patent Application (PTO-152)

Paper No(s)/Mail Date _

3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)

6) Other: ____.

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1, 8-11, 24, 30-32, 39-41, 52, 59-62, & 72 are rejected under 35 U.S.C. 102(e) as being anticipated by Mann et al. (US 6,768,149).

Re claims 1, 30 & 52, Mann et al. teach an image sensor, comprising (Fig.3):

a substrate; an array of pixel cells formed at a surface of the substrate, wherein each pixel cell comprises a transistor formed adjacent to a photo-conversion device (310), transistor comprising a gate (304) and a channel region under the gate, the gate comprising first (312) and second (314) gate regions each having a having a workfunction greater than a work-function of N⁺Si, the channel region comprising first and second channel portions under the first and second gate regions, respectively. See also Col.4, line 53-Cool.5, line 40.

Re claims 8, 39 & 59, Mann et al. teach at least one gate region comprises a layer of lower doped polysilicon of a first or second conductivity type.

Re claims 9, 40 & 60, Mann et al. teach at least one gate region has a dopant profile allowing for at least partially depletion of the at least one gate region.

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Re claims 10 & 61, Mann et al. teach the dopant is indium.

Re claims 11, 41 & 62, Mann et al. teach there is approximately no active dopant in at least one portion of the channel region.

Re claims 31-32, Mann et al. teach the image sensor is a CMOS image sensor or a charge coupled device image sensor.

Re claims 24 & 72, Mann et al. Teach a pixel cell comprising:

A photo-conversion device; and a transistor formed adjacent to the photo-conversion device, wherein a gate of transistor is a mid-gap material. By the definition, mid-gap materials are those materials having a work-function falling between the work-functions of P+ silicon and N+ silicon (see specification paragraph 0038 on page 9). The lightly doped n and p-type silicon have a work-function between the work-functions of P+ silicon and N+ silicon.

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims **2, 7, 12-13, 33, 38, 53, & 58** are rejected under 35 U.S.C. 103(a) as being unpatentable over Mann et al. (US 6,768,149).

Re claims 2, 33 & 53, Mann et al. do not teach the transistor is a transfer transistor. However, it would have been obvious to one of ordinary skill in the art at the

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time the invention was made to use the transistor of Mann et al. as a transfer transistor since it is an intended use as matter of obvious design choice.

Re claims 7, 38 & 58, Mann et al. do not teach the gate region comprises P⁺ doped polysilicon. It would have been obvious to one of ordinary skill in the art at the time the invention was made to select the concentration of the gate electrode, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. *In re Aller*, 105 USPQ 233.

Re claims 12-13, Mann et al. do not explicitly teach a second transistor formed over the substrate. It would have been obvious to one of ordinary skill in the art at the time the invention was made to form a plurality of transistors, such as reset, amplify and transfer transistors, in order to operate the image sensor properly.

5. Claims **3-6, 34-37, & 54-57** are rejected under 35 U.S.C. 103(a) as being unpatentable over Mann et al. in view of Ponomarev (Gate-Work-function Engineering Using Poly-(Si,Ge) for High-Performance 0.18 μm CMOS Technology, IEDM 1997).

Mann et al. do not teach gate region comprises a mid-gap material including SiGe. Ponomarev et al. teach forming gate electrode using SiGe to control the gate work-function. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to replace the polysilicon gate electrode with a mid-gap material since threshold voltage can be controlled easily without threshold voltage adjustment implantations.

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6. Claims **49-51** are rejected under 35 U.S.C. 103(a) as being unpatentable over Mann et al. in view of Boon (US 6,198,087).

Mann et al. do not teach a processor and an image sensor coupled to the processor. It is conventional in the art and also Boon teaches the image sensor coupled to the processor. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to couple the image sensor to the processor in order to operate the system properly.

Response to Arguments

7. Applicant's arguments filed 5-25-05 have been fully considered but they are not persuasive.

Applicant argues that Mann fails to disclose "first and second gate regions each having a work-function greater than a work-function of N+ Si". This is not convincing.

The lightly doped N-type gate region has a greater work-function than N+ Si.

Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Donghee Kang whose telephone number is 571-272-1656. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Steve Loke can be reached on 571-272-1657. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Donghee Kang Primary Examiner Art Unit 2811

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